

JPW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2814
Examiner: Long PHAM

In Re PATENT APPLICATION Of:

Applicants : Jiro MATSUMOTO)
)
Appln. No. : 10/727,662)
)
Filed : December 5, 2003)
)
For : SEALING APPARATUS FOR)
 SEMICONDUCTOR WAFER, MOLD OF)
 SEALING APPARATUS AND)
 SEMICONDUCTOR WAFER)

RESPONSE

Attorney Ref.: F00ED0150-DIV)

May 16, 2007

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Office Action mailed February 27, 2007,
please reconsider the above-identified application as follows: